

REPLACEMENT SHEET

Title: Semiconductor Structure with Increased
Breakdown Voltage and Method for Producing the
Semiconductor Structure
Inventor: Tilke et al.
Serial No.: 10/780,276
MMB Docket No.: 1890-0061



FIG 1

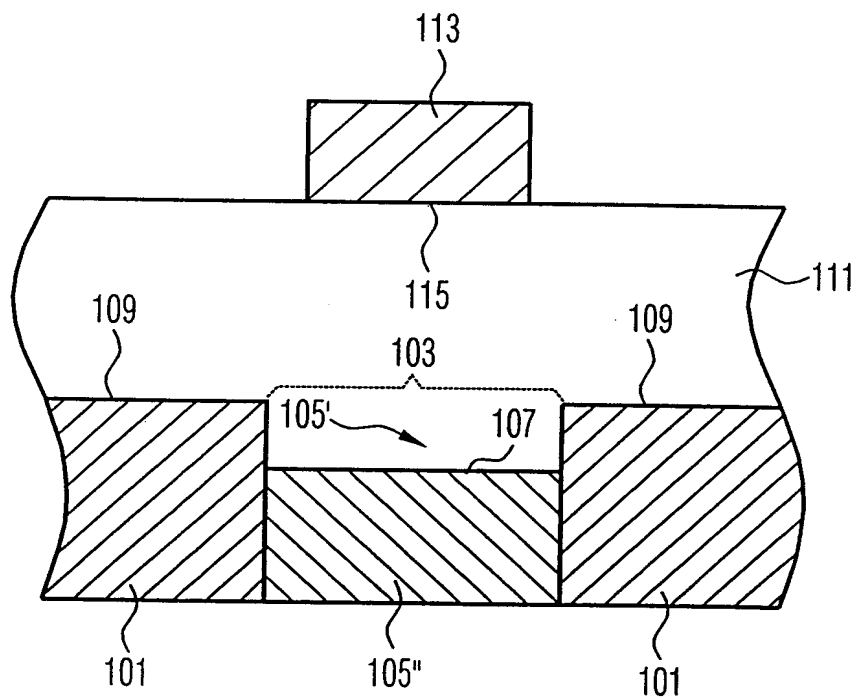


FIG 2

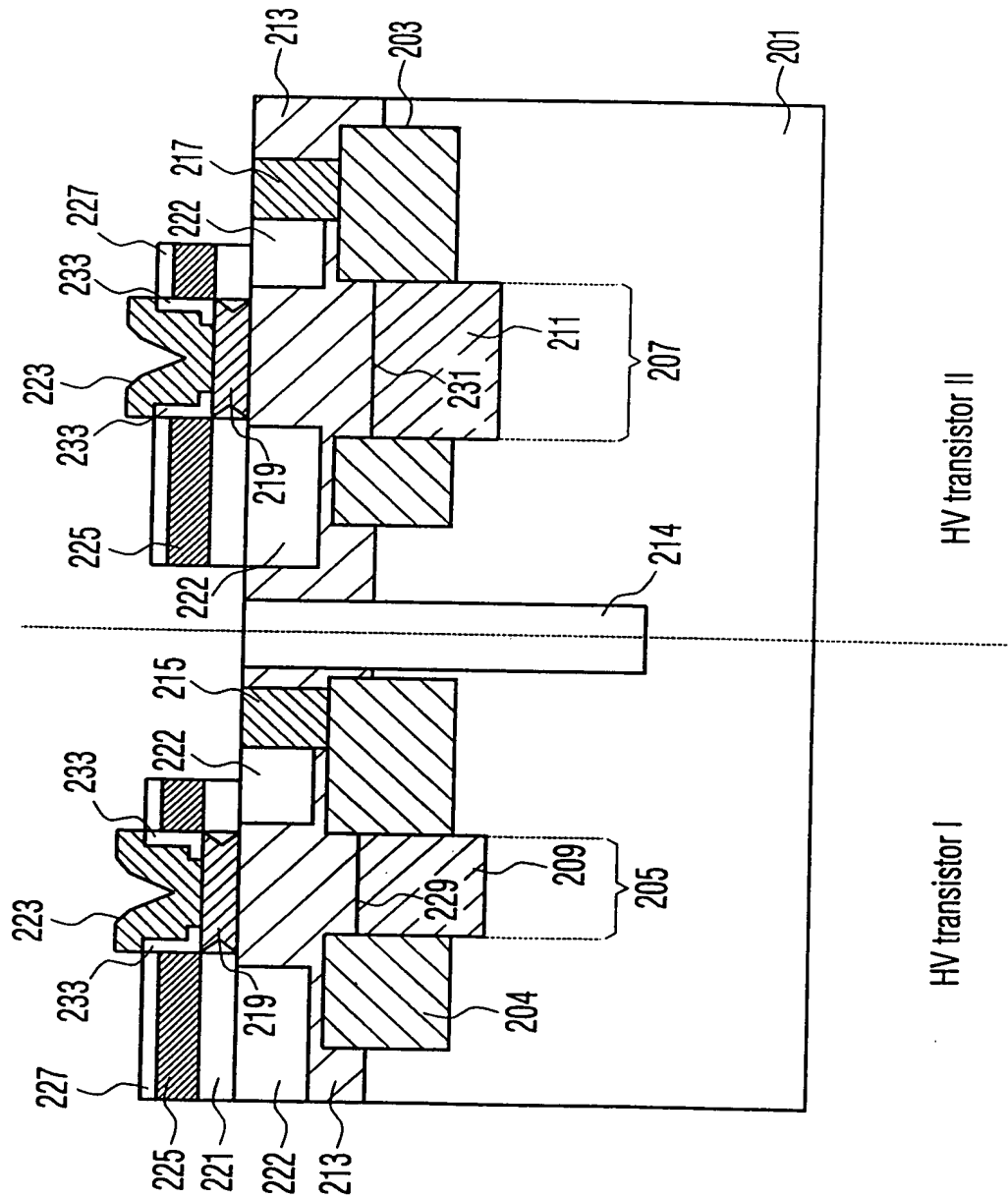


FIG 3

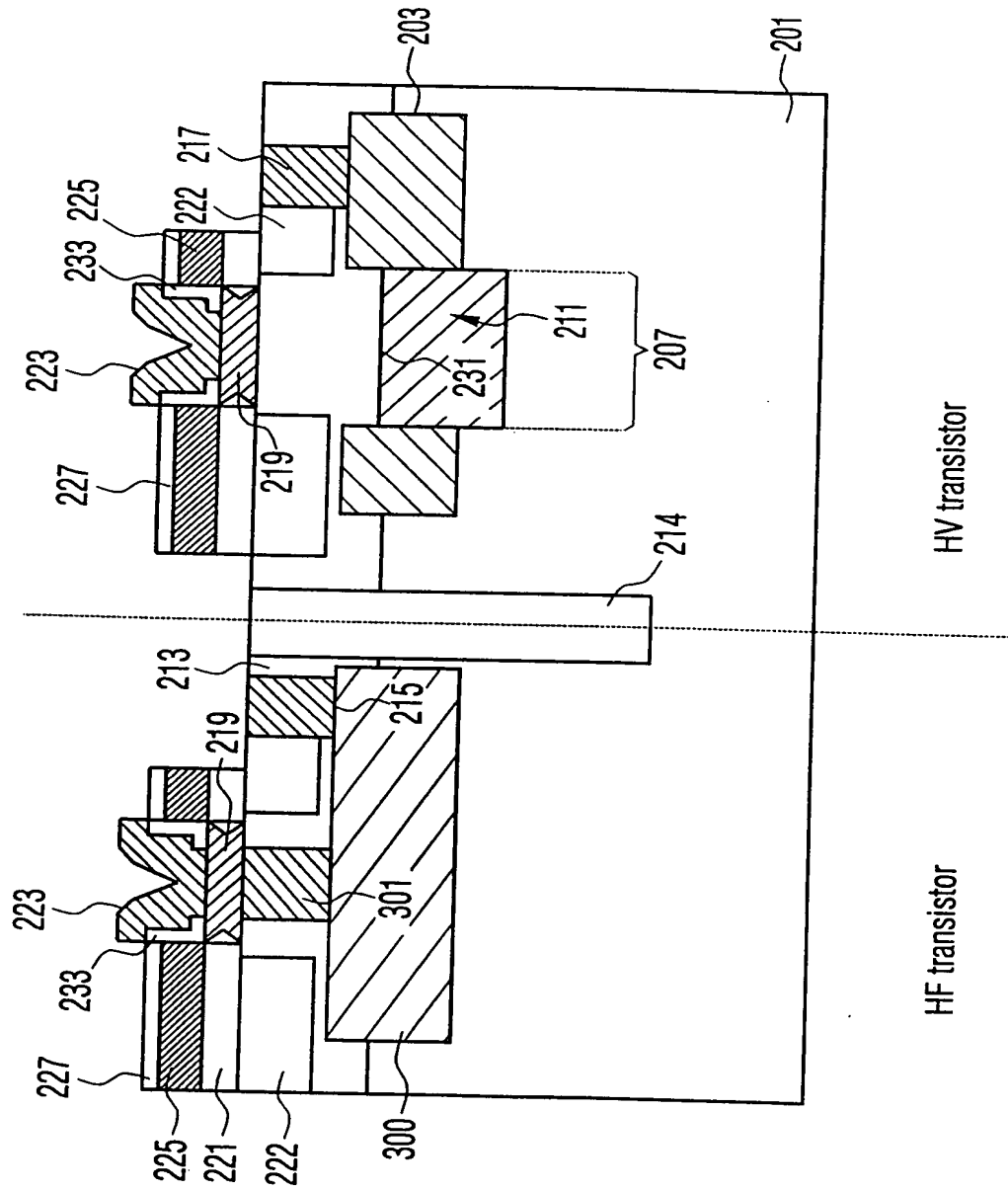


FIG 4

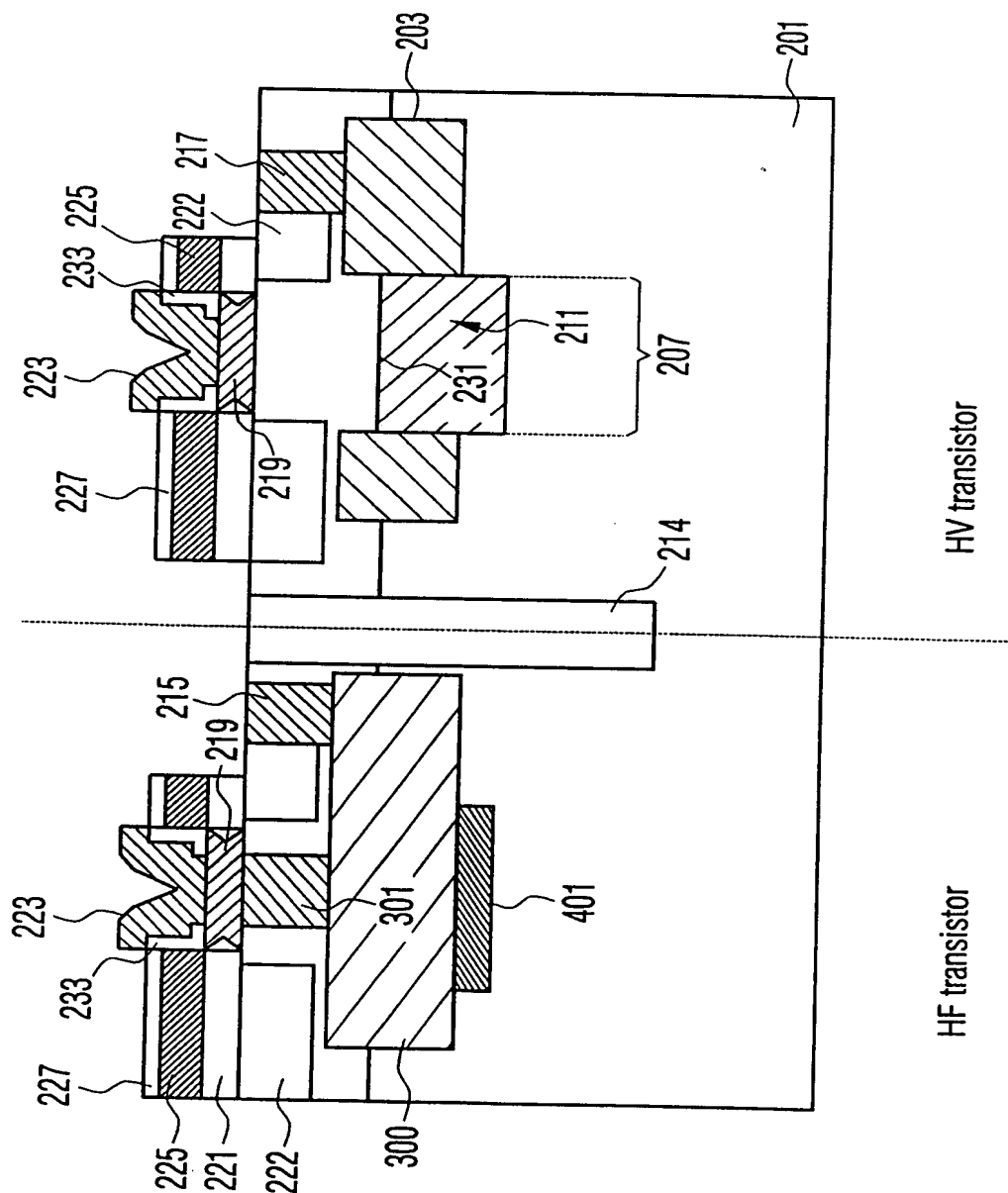
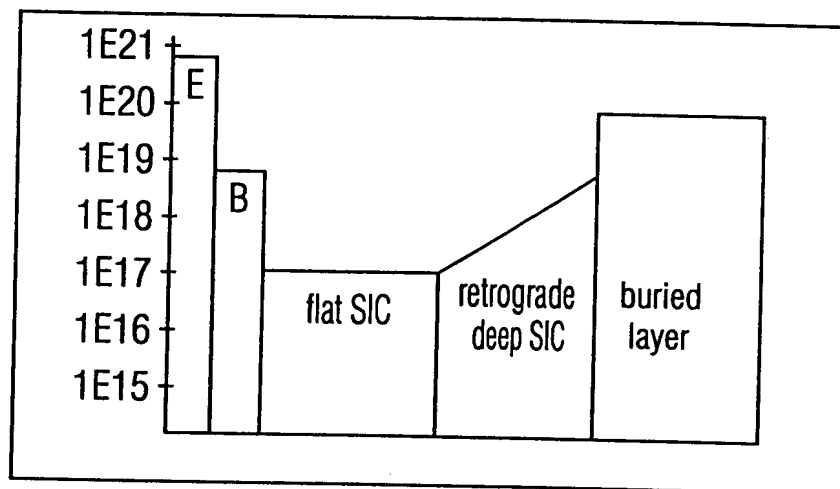


FIG 5

A)



B)

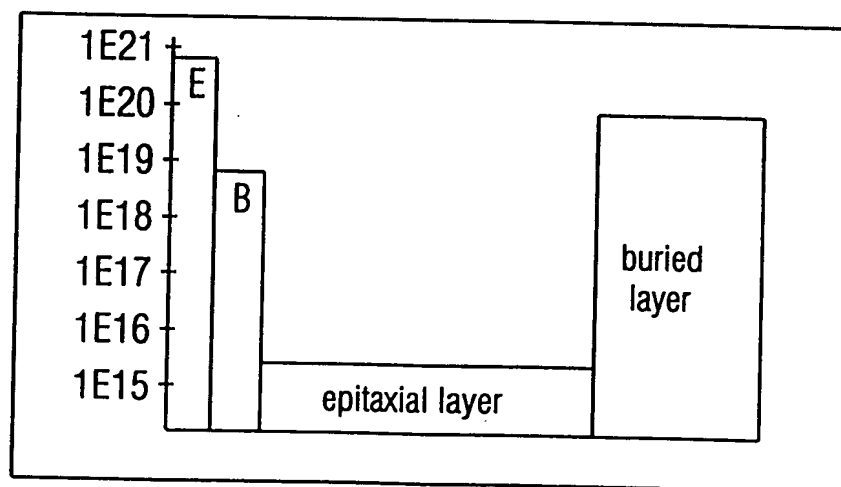
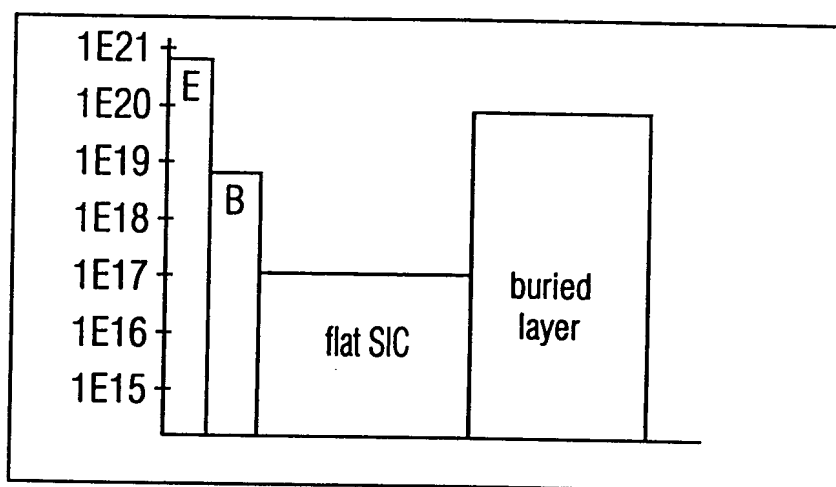


FIG 6

A)



B)

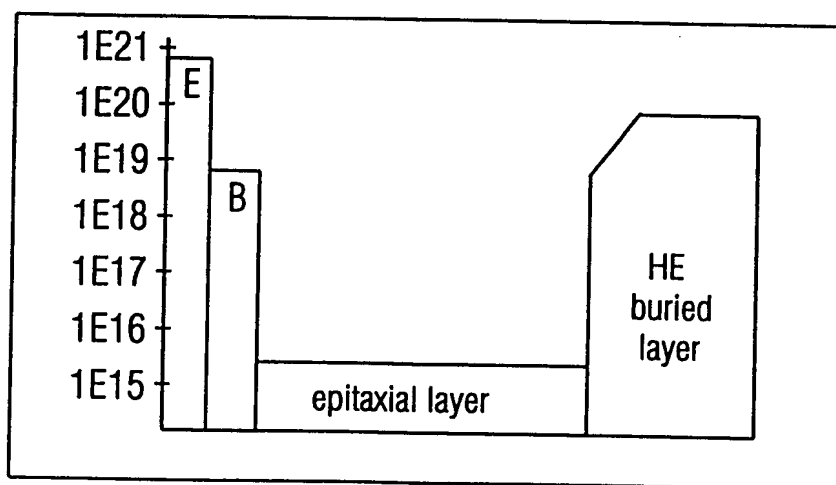


FIG 7

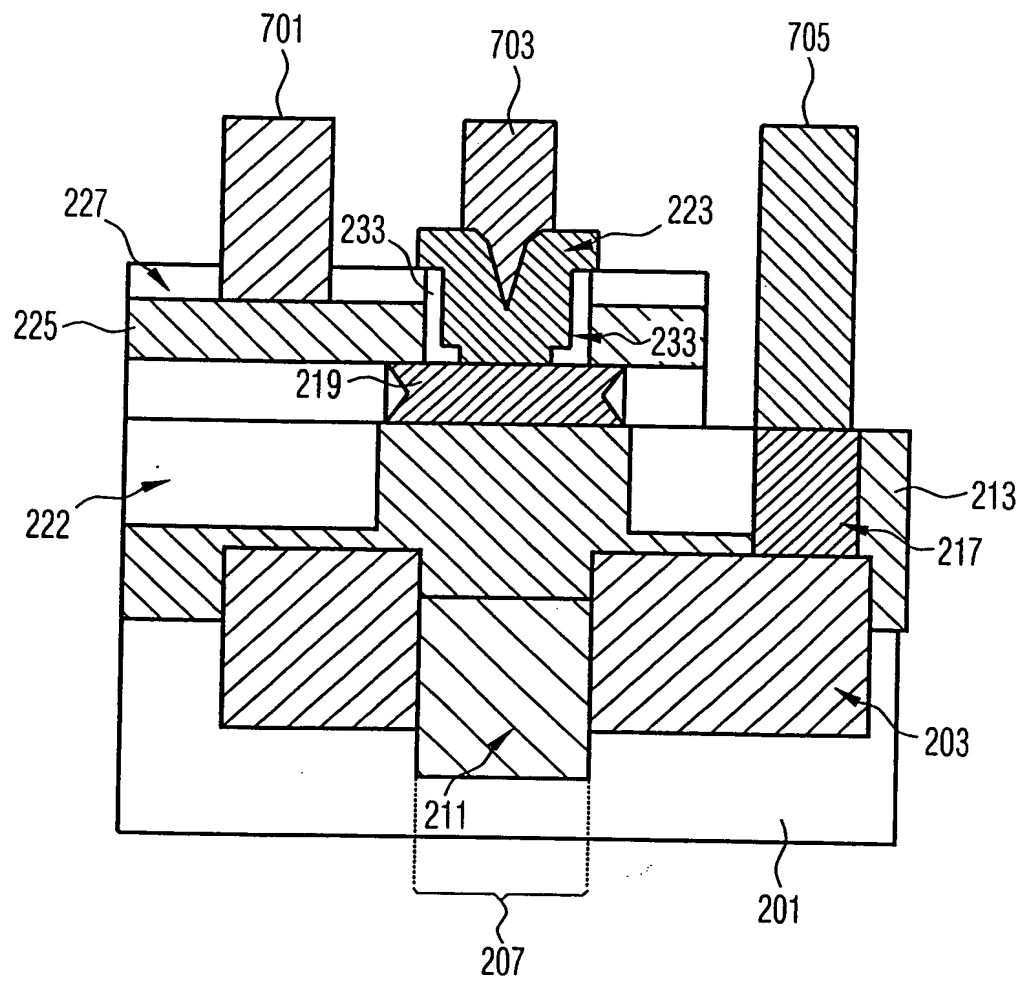


FIG 8

